



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

May 29, 2026

IGI Report Number

LG805644915

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

ROUND BRILLIANT

Measurements

7.42 - 7.44 X 4.43 MM

GRADING RESULTS

Carat Weight

1.52 CARAT

Color Grade

D

Clarity Grade

VVS 2

Cut Grade

EXCELLENT

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

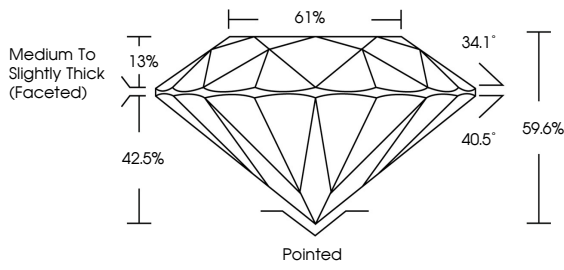
NONE

Inscription(s)

 LG805644915

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Medium To Slightly Thick (Faceted)

61%

34.1°

40.5°

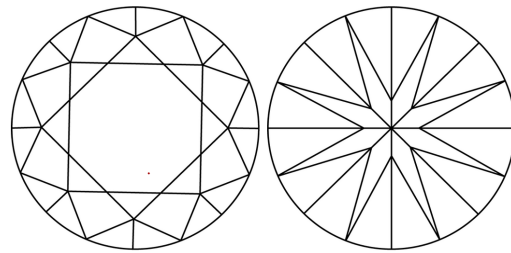
59.6%

42.5%

13%

Pointed

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



© IGI 2020, International Gemological Institute

FD - 10 20

LABORATORY GROWN DIAMOND REPORT



May 29, 2026

IGI Report Number

LG805644915

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

ROUND BRILLIANT

Measurements

7.42 - 7.44 X 4.43 MM

GRADING RESULTS

Carat Weight

1.52 CARAT

Color Grade

D

Clarity Grade

VVS 2

Cut Grade

EXCELLENT

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

 LG805644915

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



IGI

May 29, 2026

IGI Report No LG805644915

ROUND BRILLIANT

7.42 - 7.44 X 4.43 MM

Carat Weight

1.52 CARAT

Color Grade

D

Clarity Grade

VVS 2

Cut Grade

EXCELLENT

Depth

59.6%

Table

61%

Graile

Medium To Slightly Thick (Faceted)

Culet

Pointed

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

 LG805644915

Comments: The Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa